



Docket No.: 4006-150

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Chun-Lien SU

Application No. 10/054,962

Filed: January 25, 2002

Group Art Unit: 1765

Examiner: Chen, Kin Chan

For: METHOD FOR CONTROLLING AND MONITORING A CHEMICAL
MECHANICAL POLISHING PROCESS

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PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby petition the Commissioner of Patents and Trademarks to extend the time for response to the Official Action dated June 24, 2003 for one month from September 24, 2003 to October 24, 2003.

A credit card authorization form to cover the cost of the extension is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No.: 07-1337.

Respectfully submitted,

LOWE HAUPTMAN GILMAN & BERNER, LLP

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Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 310
Alexandria, Virginia 22314
Telephone: (703) 684-1111
Facsimile: (703) 518-5499
DATE: October 24, 2003
BJH:jk